FORM PTO-1449	ATTY. DKT NO. 01-149-DIV	SER. NO. 10/786,107
	APPLICANT ITO et al.	
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REFERENCE DESIGNATION

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* Full English text of the JP Document will be available in machine-translated form from JP (Japanese Patent Office) English language web site at http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX.

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EXAMINER	DATE CONSIDERED
T. M. Thomas	06-25-05

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